

METHOD FOR FORMING AN OPTO-ELECTRONIC DEVICE

ABSTRACT OF THE INVENTION

5 A method for forming an opto-electronic device through low temperature processes is provided. An active layer is bonded to a substrate by a common adhesive to maintain or increase the luminous efficiency of the opto-electronic because the electric conductive elements of the opto-electronic are formed on the active layer by a solid phase regrowth process through a low temperature
10 processe.